

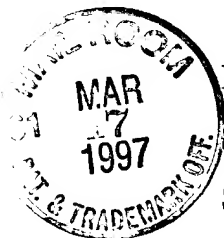
CERTIFIED MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 3-14-97

- 1 -

Docket No. 0756-958

Deborah J. Jomme



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)

Shunpei YAMAZAKI et al.)

Examiner: S. Crane

Serial No. 08/183,800)

Art Unit No. 2508

Filed: January 21, 1994)

For: SEMICONDUCTOR MATERIAL)

AND METHOD FOR FORMING)

THE SAME AND THIN FILM)

TRANSISTOR)

#35
J/S/97

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of the reference is submitted herewith in accordance with 37 C.F.R. 1.98(a), as well as the fee of \$230.

Respectfully submitted,

Jeffrey L. Costella

Jeffrey L. Costella
Reg. No. 35,483

Sixbey, Friedman, Leedom & Ferguson, P.C.
2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110